Optimization towards the demonstration of high-quality electron-beam generation from a density downramp injection in a beam driven PWFA at FLASHForward.

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Laser-ionzed density downramp injection



| Target witness bunch properties | |
|----------------------------------------|----------------|
| Energy | > 1 GeV |
| Bunch length | 1 - 20 μm |
| Transverse rms normalized Emittance | 0.01 μm - 1 μm |
| ΔΕ/Ε | ~1% |
| Current | Order of kA |

Beam-driven plasma wakefield accelerators allow for the generation and subsequent acceleration of electron beams inside the plasma with substantially lower emittance than the driving electron beam, eventually providing technology for brightness converters for versatile applications. Laser-ionized density downramp injection in PWFA has been identified as a promising injection process for this task [1,2] and recently been experimentally demonstrated for the first time [3]. At FLASHForward we find the unique facility to precisely measure the experimental properties neecssary for the development of a plasma-based electron source. Here, we report on the preparation and comissioning efforts to develop a prototype for a reliable plasma-based electron source.

Diagnostic setup



FLASHForward

Tunable plasma spikes

- Longitudinal laser for pre-ionization of Ar.
- Transverse laser ionizes Ar⁺, Ar⁺⁺ and He.
- Plasma density spike controlled via gas mixture.
- Arbitrary gas mixtures with gas mixing reservoir.

Envisioned longitudinal plasma density profile for both capillaries. Density-spike tuning via gas-mix control. 2n_{Ar}+2n_{He} o Ar⁺ - short capillary • Ar -long capillary 2n_{Ar}+n_i 2n_{Ar} 60 80 100 120 140 -20 20 40 -40 -20 20 0 40 0 z (mm) z (µm)

Plasma cell considerations



| Acceleration length for injection studies | 30 mm |
|----------------------------------------------|--------|
| Acceleration length for acceleration studies | 180 mm |
| Injection hole diameter | 300 µm |
| Pre-injection plasma length | 20 mm |



Summary

Γ

10

-20

-40

0

Diagnostics and the laser beamline, designed for the downramp injection have been set up and tested. Details

- Focussing assembly for precise positioning of injection plasma without compromising focal spot quality.
- Fast diode and cameras for coarse timing of laser arms to electron beam.
- Top-view camera for plasma-afterglow observation

Drive beam considerations



Summary

A plasma target that allows for downramp injection has been developed and tested.

Details

- Transverse holes need to be sufficiently wide for the laser spot size, required for a stable injection, but may not cause a local drop in gas pressure.
- OTR screens are installed at the capillary entrance and downstream of the capillary for spatial alignment between the laser arms and the electron beam.
- Electro-optical cristal installed as part of the electro-optical sampling.
- Injection after 20 mm > $\lambda_{hetatron}$ to ensure a repeatable injection process.

Main laser and transverse ionizing laser arm



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parameters have been identified with PIC simulations and calculations.

Details

• Drive beam peak current > 1.5 kA for injection. • Drive beam Helium ionization omitted for matched drive beam at $\epsilon_{norm}^t \sim 2 \mu m$, $\sigma_t \leq 170$ fs and Q ≤ 0.8 nC

Laser-to-beam timing

20

t(fs)

40

60









